

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Volker Härle et al.	Art Unit	: 2892
Serial No.	: 10/813,530	Examiner	: Chuong A. Luu
Filed	: March 29, 2004	Conf. No.	: 5329
Title	: METHOD FOR FABRICATING A SEMICONDUCTOR COMPONENT BASED ON A NITRIDE COMPOUND SEMICONDUCTOR		

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JUNE 26, 2008

Please amend the above-identified application as follows: